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** CONTINUING DATA *****

** FOREIGN APPLICATIONS *****

REPUBLIC OF KOREA 2003-94308 12/20/2003

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 06/05/2004

Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	KOREA, REPUBLIC OF	DRAWING 5	CLAIMS 13	CLAIMS 3
Verified and Acknowledged	Examiner's Signature	Initials			

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TITLE

Fabrication method of nitride semiconductors and nitride semiconductor structure fabricated thereby

 All Fees

FILING FEE		<input type="checkbox"/> 1.16 Fees (Filing)
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